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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	09/542,473
				Filing Date	April 4, 2000
				First Named Inventor	Takayashi IKEDA
				Group Art Unit	2826
				Examiner Name	A. Sefer
Sheet	1	of	1	Attorney Docket Number	740756-2138

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
AS		US-5,412,493		Kunii et al.	05/2/95	

FOREIGN PATENT DOCUMENTS								
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Office ³	Number ⁴	Kind Code ⁵ (if known)				
AS		JP	07-326767		Ikeda	12-12-1995		Abst.

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS				
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T ²

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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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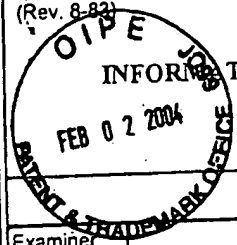
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Atty Docket 0756-2558

Serial No. 09/542,473



INFORMATION DISCLOSURE STATEMENT

Applicants: Takayuki IKEDA

Filing Date: April 04, 2000

Group Art Unit: 2826

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
AS	6,013,929	01/11/2000	Ohtani			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
AS	Specifications and Drawings for Application Serial No. 08/862,895, "Semiconductor Intergrated Circuit and Fabrication Method Thereof", Filing Date: May 23, 1997, Inventor: Hisashi OHTANI
↓	Specifications and Drawings for Application Serial No. 09/468,859, "Thin Film Transistor, Method of Manufacturing the Same, and Semiconductor Device Including the Same" Filing Date: December 21, 1999, Inventor: Hisashi OHTANI
↓	Specifications and Drawings for Application Serial No. 09/487,432, "Semiconductor Device and Process for Production Thereof" Filing Date: January 19, 2000, Inventors: Shunpei YAMAZAKI et al.
↓	Specifications and Drawings for Application Serial No. 09/493,411, "Semiconductor Device and Method of Fabricating the Same" Filing Date: January 28, 2000, Inventors: Shunpei YAMAZAKI et al.

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